

Title (en)
DEVICE FOR ADJUSTING THE DISTRIBUTION OF MICROWAVE ENERGY DENSITY IN AN APPLICATOR AND USE OF THIS DEVICE

Title (de)
VORRICHTUNG ZUR EINSTELLUNG EINER MIKROWELLEN-ENERGIEDICHTEVERTEILUNG IN EINEM APPLIKATOR UND VERWENDUNG
DIESER VORRICHTUNG

Title (fr)
DISPOSITIF DE REGULATION D'UNE REPARTITION DE LA DENSITE DE FLUX D'ENERGIE A MICRO-ONDES DANS UN APPLICATEUR, ET
UTILISATION DE CE DISPOSITIF

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Application
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Abstract (en)
[origin: US6630653B2] The invention relates to a device for adjusting the distribution of microwave energy density in an applicator which forms a resonator chamber and in which the radiation generated by microwave generators is guided to the applicator wall by waveguides; and to a use for this device. According to the invention, several electroconductive coupling pins (31) are used, each of these extending preferably vertically into both the waveguide chamber and the applicator resonator chamber, in order to feed in the microwaves with as little loss as possible and to enable the field distribution in the resonator chamber to be modified. The invention is especially suitable for producing a plasma.

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